				M -
Notice of Allowability	Application	No.	Applicant(s)	716
	10/080,064		STAKER ET AL.	
	Examiner		Art Unit	10-
	MOHAMMAD		2872	1/
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. 1. This communication is responsive to ex. interview on 2/7/03. 2. The allowed claim(s) is/are 1-17 and 19-29.				
 3. The drawings filed on 19 February 2002 are accepted by the Examiner. 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). 				
a) ☐ All b) ☐ Some* c) ☐ None of the:				
Certified copies of the priority documents have been received.				
2. Certified copies of the priority documents have been received in Application No				
3. Copies of the certified copies of the priority documents have been received in this national stage application from the				
International Bureau (PCT Rule 17.2(a)).				
* Certified copies not received: 5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application). (a) The translation of the foreign language provisional application has been received. 6. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.				
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.				
7. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.				
8. CORRECTED DRAWINGS must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No. (b) including changes required by the proposed drawing correction filed , which has been approved by the Examiner. (c) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No.				
ldentifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the top margin (not the back) of each sheet. The drawings should be filed as a separate paper with a transmittal letter addressed to the Official Draftsperson.				
9. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.				
Attachment(s)				
1⊠ Notice of References Cited (PTO-892) 3□ Notice of Draftperson's Patent Drawing Review (PTO-948 5□ Information Disclosure Statements (PTO-1449), Paper No. 7□ Examiner's Comment Regarding Requirement for Deposition of Biological Material	o	4⊠ Interview Summ 6⊠ Examiner's Ame	al Patent Application (nary (PTO-413), Paper endment/Comment ement of Reasons for	· No. <u>3</u> .

Ārt Unit: 2872

EX- Andt-u **EXAMINER'S AMENDMENT** 1 2 An examiner's amendment to the record appears below. Should the changes 3 and/or additions be unacceptable to applicant, an amendment may be filed as 4 provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST 5 be submitted no later than the payment of the issue fee. 6 Authorization for this examiner's amendment was given in a telephone interview with Mr. Kenneth Allen on 2/7/03. 7 8 The application has been amended as follows: 9 a) cancel claims 18, ର୍ଜୀ amend claim 1 as follows: 10 11 1. (Amended) A double-gimbaled micromachined mirror structure for 12 parallel-plate electrostatic operation, said mirror structure comprising: 13 a substrate of a micromirror array with embedded electrostatic 14 electrodes; 15 a mirror in said array of said substrate; a gimbal around said mirror; and 16 17 a plurality of folded longitudinal gimbal hinge structures such that a plurality of torsional hinge elements are disposed in parallel orientation to the axis of 18 19 rotation of each hinge structure, said folded longitudinal gimbal hinge structures 20 being disposed at four positions on a gimbal ring, a first pair of said folded 21 longitudinal gimbal hinge structures connecting said mirror to said gimbal and a 22 second pair of said folded longitudinal gimbal hinge structures connecting said 23 substrate to said gimbal. 24

25

26

27

REASONS FOR ALLOWANCE

The following is an Examiner's Statement of Reasons for Allowance:

Art Unit: 2872

The claims are allowable over the prior art for at least the reason that the prior art fails to reasonably teach or suggest a plurality of folded longitudinal gimbal hinge structures such that a plurality of torsional hinge elements are disposed in parallel orientation to the axis of rotation of each hinge structure, said folded longitudinal gimbal hinge structures being disposed at four positions on a gimbal ring as set forth in the claimed combination.

Any comments considered necessary by applicant must be submitted no later than the payment of the Issue Fee and, to avoid processing delays, should preferably **accompany** the Issue Fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

CONTACT INFORMATION

Papers related to this application may be submitted to Group 2870 by facsimile transmission. Papers should be faxed to Group 2870 via the PTO Fax center located in the Crystal Plaza 4. Faxing of such papers must conform with the notice published in the official Gazette, 1096 OG 30 (November 15, 1989). The CP-4 Fax Center number is (703) 308-7722.

Any inquiry of a general nature or relating to the status of this application should be directed to M. Sikder whose telephone number is (703) 305-5471.

MOHAMMAD SIKDER PRIMARY EXAMINER

51 February 8, 2003